

1	Number	White conductive (e.g. metal, polymer) film, near10 (near10, IN)	US-10221984	US-10221984
-	-	-	US-10221984	US-10221984
-	-	1. (contact adj hole near10 passivation and gate adj insulating) near10 drain	US-10221984	US-10221984
-	-	931 contact adj hole near10 passivation	US-10221984	US-10221984
-	-	662 contact adj hole near10 gate adj insulating	US-10221984	US-10221984
-	-	46 (contact adj hole near10 edge or side) near10 drain adj electrode	US-10221984	US-10221984
-	-	9 ((contact adj hole) near10 (passivation) and (contact adj hole, near10, gate adj insulating) and (contact adj hole) near10 (edge or side) near10 (drain adj electrode))	US-10221984	US-10221984
-	-	190 (semiconductor adj layer) near10 (chmic adj contact adj layer) near10 (gate adj insulating)	US-10221984	US-10221984
-	-	10 ((source and drain) adj electrode) near10 (chmic adj contact adj layer)	US-10221984	US-10221984
-	-	4 ((semiconductor adj layer, near10 (chmic adj contact adj layer) near10 (gate adj insulating)) and ((source and drain) adj electrode) near10 (chmic adj contact adj layer))	US-10221984	US-10221984
-	-	158 (semiconductor adj layer) near10 (gate adj insulating, near10 above near10 (gate adj electrode))	US-10221984	US-10221984
-	-	6 (contact adj hole) near10 over near10 (drain adj electrode) near10 (pixel adj region of area)	US-10221984	US-10221984
-	-	6 contact adj hole near10 over near10 drain adj electrode near10 pixel adj region of area	US-10221984	US-10221984
-	-	source and drain adj electrode near10 opposite adj sides near10 semiconductor adj layer	US-10221984	US-10221984

1	source and drain adj electric to nearil. semiconductor adj layer	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
2	semiconductor adj layer nearil gate adj insulating nearil above nearil gate adj electrode and source and drain adj electric to nearil. semiconductor adj layer	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
3	drain adj electrode nearil reduced nearil size or area	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
4	contact adj hole nearil edge or side- nearil drain adj electrode and drain adj electrode nearil reduced nearil size or area	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
5	contact adj hole nearil drain adj electrode nearil pixel adj region	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
6	contact adj hole nearil over nearil (drain adj electrode) nearil over nearil pixel adj region	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:41:00
376	contact adj hole nearil (passivation) nearil exposed (drain adj electrode) nearil insulating	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:44:00
20	(contact adj hole) nearil (passivation nearil exposed nearil (drain adj electrode) nearil (insulating)	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/14 16:44:00
9	(contact adj hole) nearil formed nearil over nearil 'drain and pixel'	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/15 01:41:00
1	6532050.did.	USPAT; US-PSFTB; EPO; JPO; DERWENT; IBM TDB	2003/03/15 09:50:00